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12-03-2001

(REV. 6-93)

OMB No. 07\651-0011 (exp. 4/94)



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Ofer DU-NOUR;
Yaron ISH-SHALOM

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Execution Date:

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If this document is being filed together with a new application, the execution
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Name: **SOL SHEINBEIN**Internal Address: **c/o ANTHONY CASTORINA**Street Address: **2001 JEFFERSON DAVIS HWY.****SUITE 207**City: **ARLINGTON** State: **VIRGINIA** ZIP: **22202**

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ASSIGNMENT

For good and valuable consideration, the receipt and sufficiency of which is hereby acknowledged, the undersigned:

Ofer DU-NOUR
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hereby sell(s), assign(s) and transfer(s) to:

Tevet Process Control Technologies Ltd.
P.O. Box 5667
23 513 Migdal Haemek
Israel

(hereinafter called the "Assignee"), its successors, assigns, nominees or other legal representatives, the undersigned's entire rights, title and interest in and to the invention titled:

Method And Apparatus For Measuring Stress In Semiconductor Wafers

described and claimed in the following Patent Application:

Patent Application to be filed in the USA
identified as Attorney Docket No. 01/21787

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and agree(s) to sign all lawful papers, make all rightful oaths, do all lawful acts requisite for such Patent Applications, and do everything possible to aid said Assignee to apply for, obtain and enforce Patent protection for said invention.


Ofer DU-NOUR

Date: 20/11/01


Yaron ISH-SHALOM

Date: 20/11/01